

PTO/SB/08A (04-03)

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(Use as many sheets as necessary)

Complete if Known

Application Number	Not Known Yet 10/840 093
Filing Date	05/06/2004
First Named Inventor	Chao-Lung Chen
Art Unit	Not Known Yet 2813
Examiner Name	Not Known Yet
Attorney Docket Number	N1085-00288

Sheet	1	of	2
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U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

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Examiner Signature	/Thanh Nguyen/ (04/28/2006)	Date Considered	04/28/2006
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Sheet

2

of

2

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
TN	H	SATO ET AL., "Newly Developed Electro-Chemical Polishing Process of Copper as Replacement of CMP Suitable for Damascene Copper Inlaid in Fragile Low-k Dielectrics", Electron Devices Meeting, 2001. IEDM Technical Digest. International, 2-5 Dec. 2001, Pages 4.4.1 - 4.4.4	
TN	I	GRANDIKOTA ET AL., "Influence of Plating Parameters on Reliability of Copper Metallization", Interconnect Technology Conference, 2002. Proceedings of the IEEE 2002 International, 3-5 June 2002, Pages 197 - 199	

Examiner
Signature

/Thanh Nguyen/ (04/28/2006)

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